# POZNARO POZNAR

#### POZNAN UNIVERSITY OF TECHNOLOGY

EUROPEAN CREDIT TRANSFER AND ACCUMULATION SYSTEM (ECTS)

# **COURSE DESCRIPTION CARD - SYLLABUS**

Course name

Microscopy methods in materials testing [S1MiTPM1>MMwBM]

Course

Field of study Year/Semester

Materials and technologies for automotive industry 2/4

Area of study (specialization) Profile of study

general academic

Level of study Course offered in

first-cycle Polish

Form of study Requirements full-time compulsory

**Number of hours** 

Lecture Laboratory classes Other

15 15 0

Tutorials Projects/seminars

0 0

Number of credit points

2,00

Coordinators Lecturers

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#### **Prerequisites**

Basic knowledge of chemistry, physics, and materials science. Logical thinking, use of the information obtained from the library and the Internet. Understanding the need for learning and acquiring new knowledge.

#### Course objective

Learning microscopy methods for examining materials.

### Course-related learning outcomes

#### Knowledge:

- 1. The student should know the microscopy methods of examining materials.
- 2. The student should know the preparation methodology for various microscopy methods.
- 3. The student should know the physical basis of various microscopy methods.

#### Skills:

- 1. The student is able to select a research method leading to obtaining the correct result.
- 2. The student is able to perform a metallographic cross-section and interpret the obtained structure.

- 3. The student is able to interpret the structure using electron microscopy.
- 4. The student is able to examine the chemical composition using X-ray microanalysis.

### Social competences:

- 1. Student is able to work in a group.
- 2. The student is aware of the importance of modern microscopy methods in the study of materials in the modern economy and for society.

#### Methods for verifying learning outcomes and assessment criteria

Learning outcomes presented above are verified as follows:

Lecture: - credit on the basis of a test consisting of both open and test questions carried out at the end of the semester. Scale of estimate: 51-60% - dst(C), 61-70% - dst+(C+), 71-80% - db(B), 81-90% - db+(B+), 91-100% - bdb(A).

Laboratory classes: evaluation of students knowledge necessary to prepare, and carry out the lab tasks and evaluation of reports.

### Programme content

During the course, the student will learn the methods of light and electron microscopy.

# **Course topics**

Lecture: Light microscopy - structure and operation of a metallographic microscope, research methods, preparation. Quantitative metallographic methods in microscopy. Scanning electron microscopy, principle of operation and structure of a scanning electron microscope, research methods and their scope of application, sample preparation, interpretation of obtained images. Microanalytical studies in electron microscopy. Transmission electron microscopy - physical basics, structure and operation of a microscope, basic research methods, preparation. Basics of X-ray microanalysis.

Laboratory classes: 1. Light microscopy - preparation of metallographic sections (part 1). 2. Light microscopy - preparation of metallographic sections (part 2) 3. Microscopy observations. 4. Quantitative metallography methods in microscopy. 5. Scanning electron microscopy with basic EDS X-ray microanalysis.

## **Teaching methods**

multimedia presentations.

#### **Bibliography**

#### Basic:

- 1. A. Barbacki (red.), Mikroskopia elektronowa, Wyd. PP, 2007.
- 2. A. Barbacki (red.), Metody i techniki strukturalnych badań metali, Wyd. P.P., Poznań 1994.
- 3. L.A. Dobrzański, E. Hajduczek, Metody badań metali t. 2, WNT 1987.

#### Additional:

1. Kurzydłowski K., Lewandowska M., Nanomateriały inżynierskie konstrukcyjne i funkcjonalne, Wyd. PWN. 2010.

### Breakdown of average student's workload

	Hours	ECTS
Total workload	55	2,00
Classes requiring direct contact with the teacher	30	1,00
Student's own work (literature studies, preparation for laboratory classes/ tutorials, preparation for tests/exam, project preparation)	25	1,00